



17TH ADVANCED BEAM DYNAMICS WORKSHOP ON

FUTURE LIGHT SOURCES

WG4 Summary Viewgraphs

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Insertion Device Development for 4th generation light sources

- coherent light at 10 keV
high brightness at even higher energies
- circularly polarized light (variable)
- small amount of "waxels" on axis
power density
minor contamination with higher harmonics
- short pulses
- tunability by users

these demands trigger the following
technical developments in insertion device design:

high energies

SASE FEL

- high magnetic field quality
- alignment of modules
- beam based alignment
- integrated diagnostics
and steering coils
- integrated focussing

Storage rings

wigglers

undulators

storage ring

wiggler: higher fields

- permanent magnet wiggler 3,6 T @ 600 mm (ESRF)
- electromagnetic devices > 3 Tesla (LBNL, in study)

- superconducting multipole wiggler 47 poles 3.5 Tesla $\lambda = 60 \text{ mm}$ (MAX LAB)

- superconducting WCS (10 Tesla already demonstrated)

undulator smaller periods lower gaps

- in vacuum IDS
- mini-micropole IDS

higher harmonics

- phase shimming

circularly polarized light
control of higher harmonics

SASE-FEL

- "crowned undulator" (Kim) (no monochromator needed)
- superconducting helical devices
- planar helical (permanent magnet)

tenability

storage ring

- many devices with permanent magnets
- electromagnets

SASE

- e⁻ energy variation (how fast?)
- helicity switching (dispersion optics)

Storage ring

- gap variation at long IDS
- polarization switching
- ID-monochromator coupling

long undulation for storage rings

- optimum segmentation length: $\sim 2,5 \text{ m}$
- phasing between segments
 - i) magnetically one piece but mechanically decoupled (SPRING, BETTY...)

ii) gap of several mm

pure permanent magnet:
special termination
developed at ESRF

hybrid:
no solution yet

- strong focussing for small gap IDs (Toschyn)
- synchronization of axis within a few μm if high harmonics shall be used
 - closed loop, direct gap reading
 - compensation of Abbe comparison error (which is due to beam roll)

- coupling with monochromator

stop and go mode
realized at
several facilities

continuous mode
not yet realized

Challenges for SASE undulators

specs: trajectory errors have to be minimized to guarantee overlap of electron beam and photon beam.
phase error do not play dominant role.

this implies:

- tight field tolerances: $\pm 1\%$ can be achieved with conventional tools, however it is necessary for noise reduction
- ii) calibration of Hall probes

- additional focussing: field gradient ~~must~~ $\Rightarrow$ precise alignment of quadrupoles essential
- ID cannot be measured completely in one scan $\Rightarrow$ representation (TCLA and VISA: 2 modules can be measured in combination)
- alignment of modules:
 - i) align quadrupoles within individual modules
 - ii) transfer quadrupole centres to fiducials
 - iii) align fiducials of different modules with 10 μ m precision
 - iv) beam based alignment
(varying e^- energy instead of quad-settings)

Challenges of SASE undulators: 3 examples

	APS	TESLA	VISA
energy (MeV)	220 700	230-390 1000	72 220
λ (nm)	532 52	120-40 6,4	814 87
undulator design	hybrid (Undulator A with fixed gap girder)	hybrid	pure permanent magnet, <u>in vacuum</u>
gap (mm)	9,3	12,0	6,0
total length (m)	30	15/30	4/6
B (T)	1,01	0,497	0,75
magnet sorting	yes after sorting much better	yes	yes blocks
shimming	conventional (iron chims)	pole height adjustment	movement of quadrupoles + trim magnets
measurement	Hallprobe / coil	Hallprobe / coil	pickel wire
achieved accuracy		<u>5 μm^2</u>	
<u>integrated focusing</u>	no: natural focusing + hor. f. quad between sections	yes	yes
focusing strength		12 T/m	33 T/m

APS

TESCA

VISA

measurement
of quadrupole +
transformations to
fiducials

wire trans-
versely moved

pulled wire,
say test: $0^\circ + 90^\circ$
measurement

accuracy of
adjustment
of quad center &
transformations to
fiducials

$\pm 50 \mu m$

$\pm 25 \mu m$

module length
(cm)

2.4

4.5

1.0

BPM + clearance
inside undulator

no

every 0.5 m

every 0.5 m

diagnostics
skere between
modules

yes

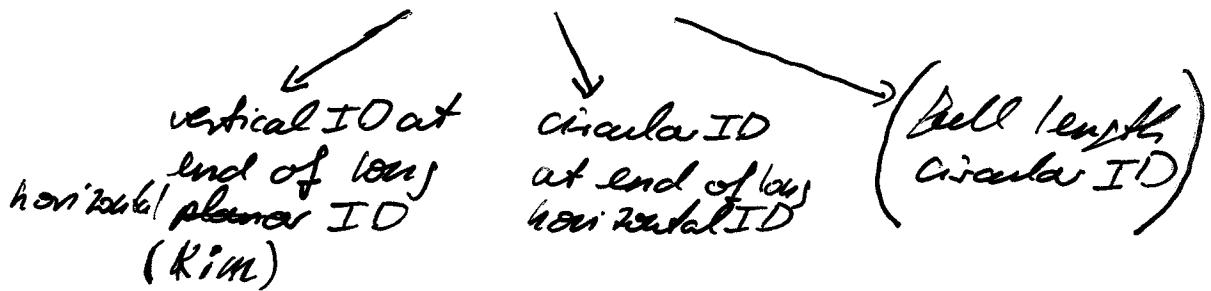
wire scanner
absolute
accuracy $\pm 10 \mu m$

magnetically
one ID,
mechanically
repeatedly
adjustable

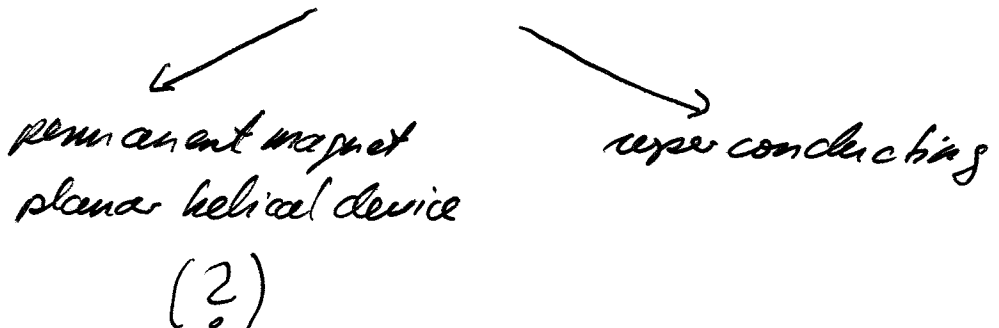
further development of SASE undulators
(as now as principle has been proven by experiment)



circularly polarized light is
highly demanded by users



improve performance of SASE undulator
with full length helical device

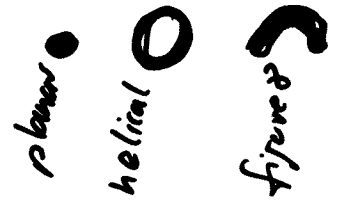


- automatic (robotic) shimming (Ramien SB)

new magnet designs for:

- len on axis power density
- len higher harmonics contamination
- variable polarization

power density:

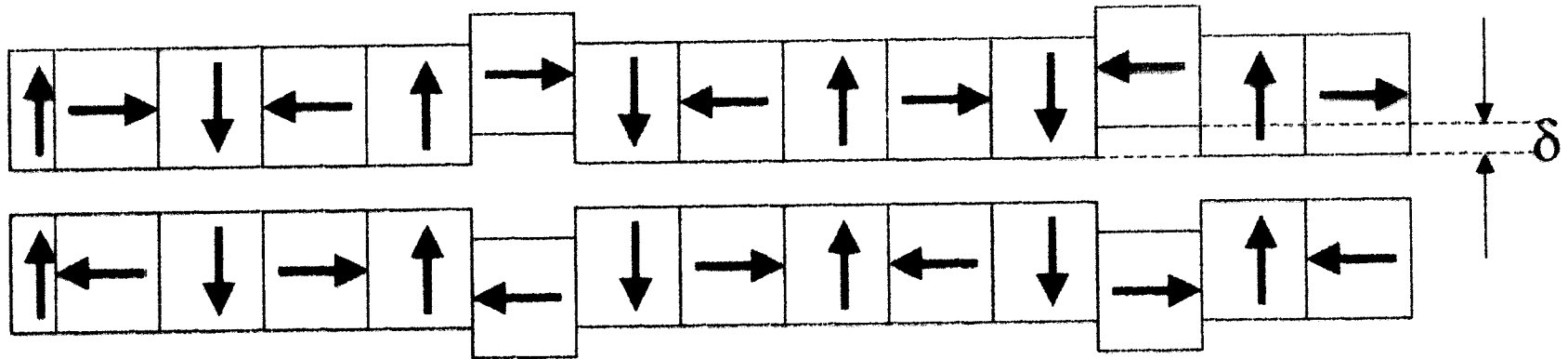


design	polarization	len on axis power density	len higher harmonics contamination	complexity		# rows	Status
				blocks/period	# movable rows		
new QPC	hor. linear	no	yes	8	1	2	built BRT
APPLE QPC	variable	yes (circular)	yes	16	2	4	planned ELETTRA
figure 8	hor/vertical linear	yes	yes	16	1	6	built SPRING8
vertical undulator	vert. linear	no	no	16	1	4	built SPRING8
SPRING8 type EPC	variable	yes (circular)	yes	24		6	built SPRING8
APPLES	variable	yes	yes	24	2	4	proposed
PERA	vert. linear	yes	yes	14	1	6	proposed
wound EPC	variable	yes (linear)	yes	16	2	4	under const. BESSY
helical ID + higher harmonics	helical	no	no	48	1	6	proposed

New quasiperiodic scheme (Sasaki)

built or can be constructed at several places

- permanent magnet designs (ESPT, ELECTRA)
- electromagnetic designs (SLS)

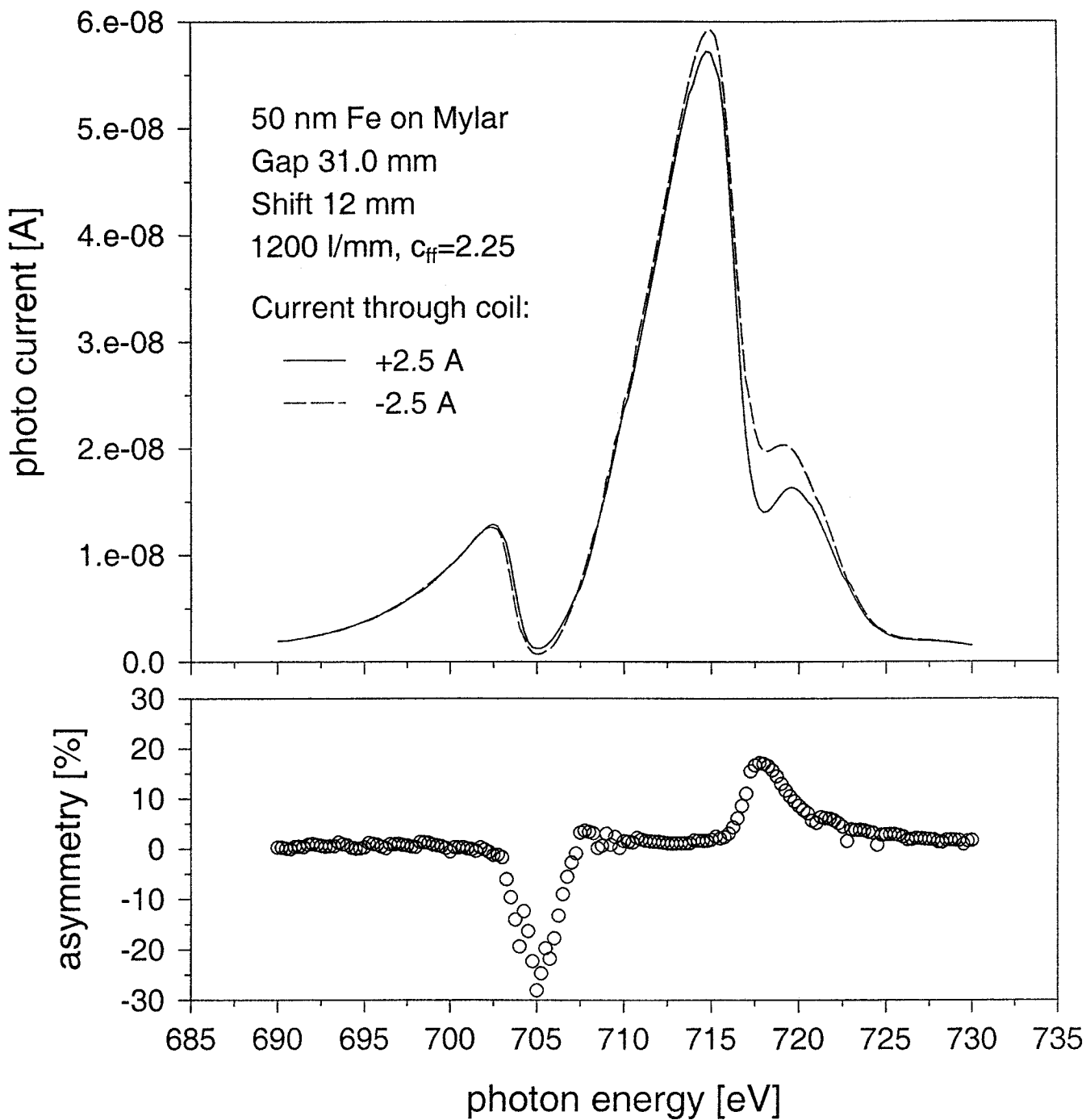


Circularly Polarizing Undulators (Sasaki Type) in Operation or under Construction (17.2.1999)

Facility	period length (mm)	total length (m)	Status (Feb. 1999)
SSRL	65	1.8	in operation for 5 years (second generation storage ring)
ALS	50	2	commisioning phase
SPRING 8	120	2	commisioning phase
SRRC	56	4	installation: April 1999
PLS	60	2.5	under construction
ELETTRA	60	2	under construction
	125	2	under construction
	46	2	under construction
	76	2	under construction
BESSY II	56	2 x 1.8	under construction
	56	2 x 1.8	under construction
	45	3.4	to be operational

ESRF

First circularly polarized light at BESSY II UE56/1, 31.3.1999



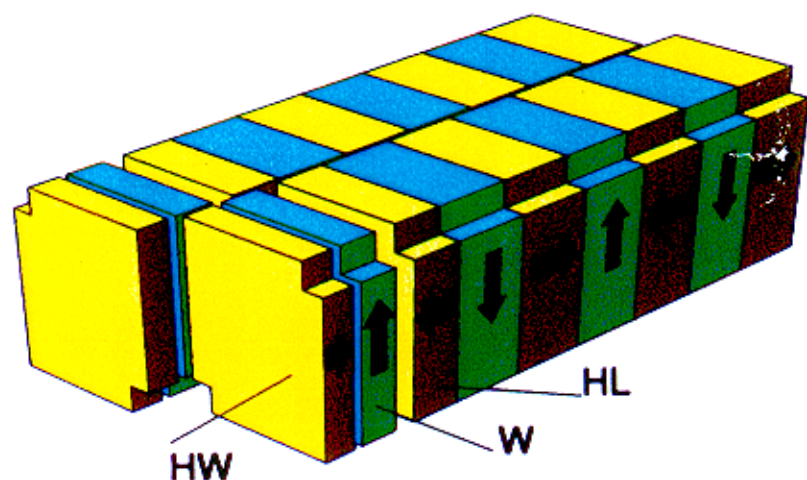
"Surprises" with new circularly polarizing permanent magnet devices

- field integrals dependent on gap + phase due to non unity of permeability of magnets
solution: new end pole termination (ESPT)
 - old shimming techniques not applicable (shims move or change sensitivity during phase operation)
elaboration of new shimming schemes:
 - i) magnet block movement (hor. + vert.)
 - ii) non shims in special configuration
 - iii) permanent magnet shims
 - forces change direction?
careful FEM based construction of mechanics
- ⇒ with this in mind I/Os can achieve ~~probably~~ same quality as planar devices.

New Termination for an Apple II Undulator

- J. Chavanne et al., Presented at PAC 99

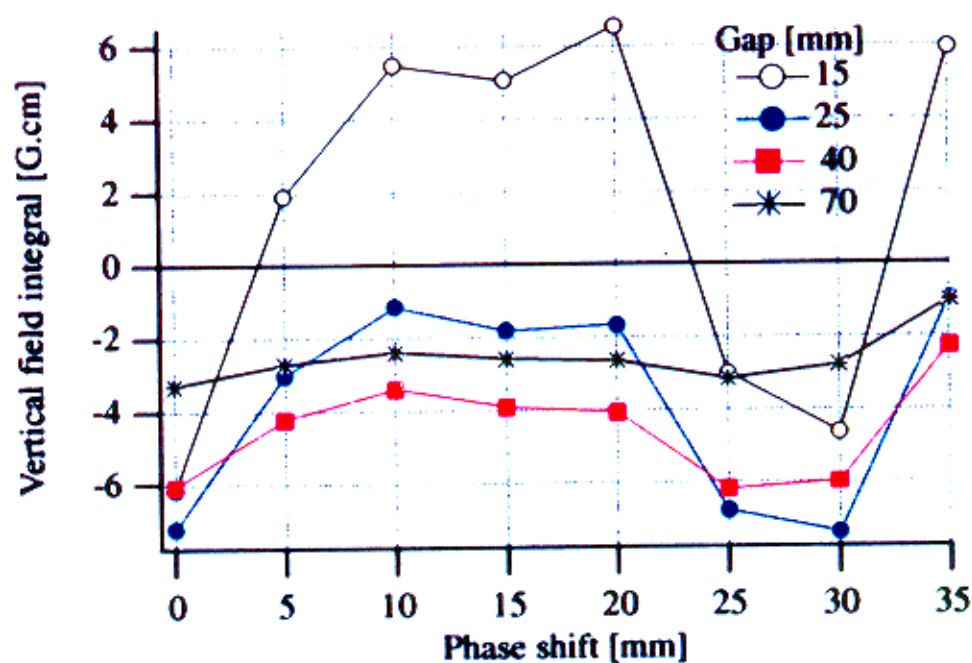
- Computed with Radia



NdFeB Magnets

Period = 70 mm

Symmetric Vertical Field



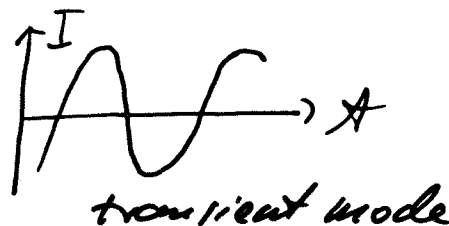
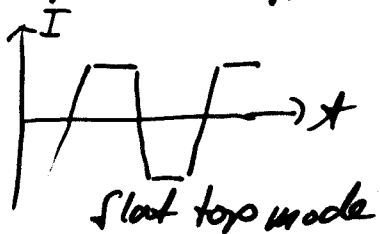
Magnet Block Quality

- it is still necessary to do both:
 - i) sorting
 - ii) shimming(at least for permanent magnet devices)
- some vendors accept tight tolerances on inhomogeneities (North South pole $\leq 0,5\%$) but not all !
- 1 number might not be sufficient to characterize inhomogeneities
 - supply vendor with equipment to characterize blocks more carefully in house

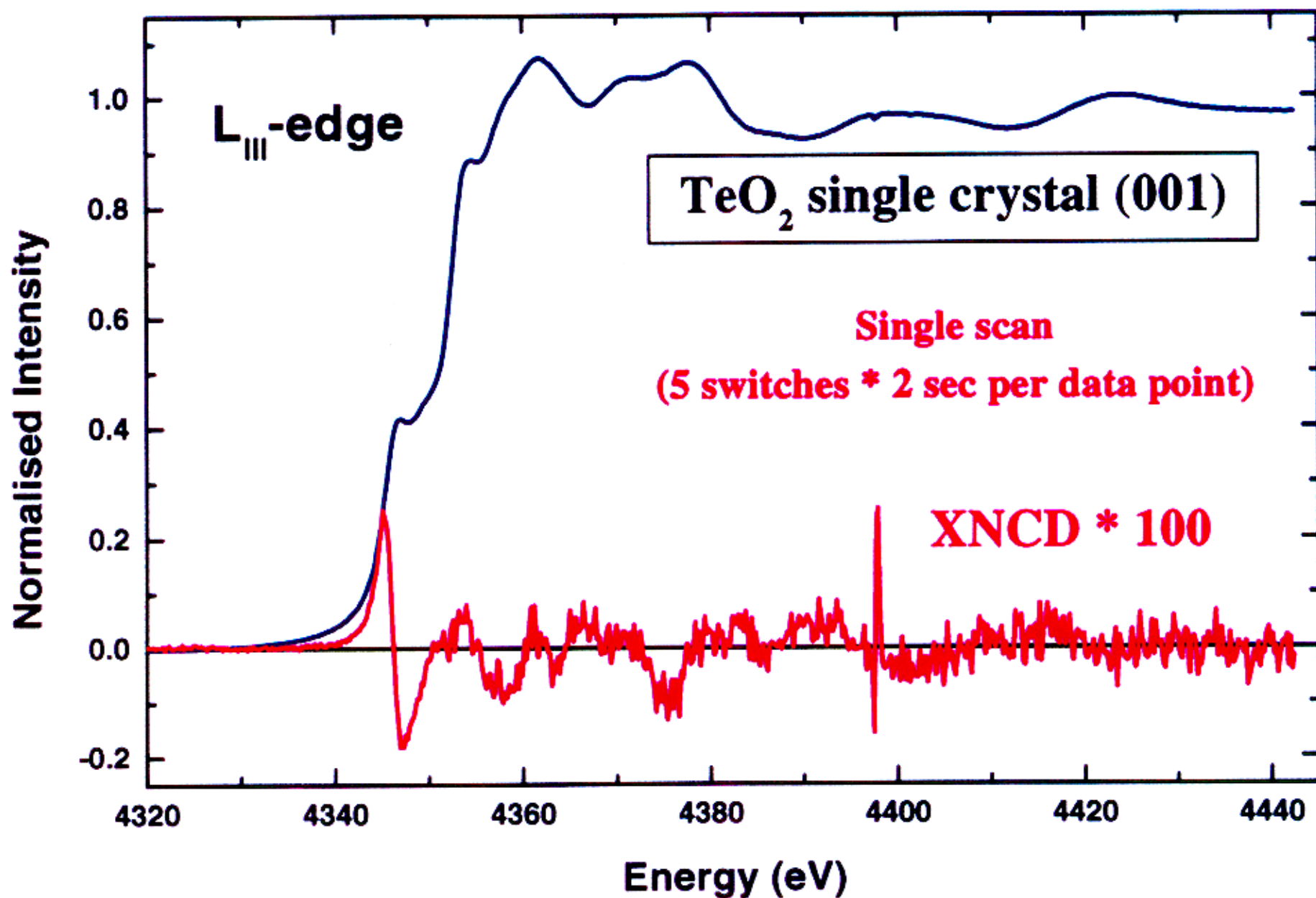
Electromagnetic elliptical/helical undulators (only new devices)

design	polarization	switching rate		states
		typical	max.	
coils + permanent magnets	elliptical	2 / 100	100 Hz	B NSLS in operation
coils + permanent magnets	elliptical	1	10	APS in operation
electro-magnet	helical or elliptical		10 Hz	ELETTRA in operation
coils + permanent magnets	helical	1 Hz	10 Hz	ESRF in operation

- dynamical changes of field integrals are compensated (DSP ...) $\rightarrow$ transparent IDS
NSLS: $f \leq 10$ Hz: combination of feed forward and feed back
- hysteresis effects can be handled
- undulators require flat top mode $\rightarrow f \leq 10$ Hz
- elliptical wiggles work also in transient mode



FIRST TEST OF EMPHU

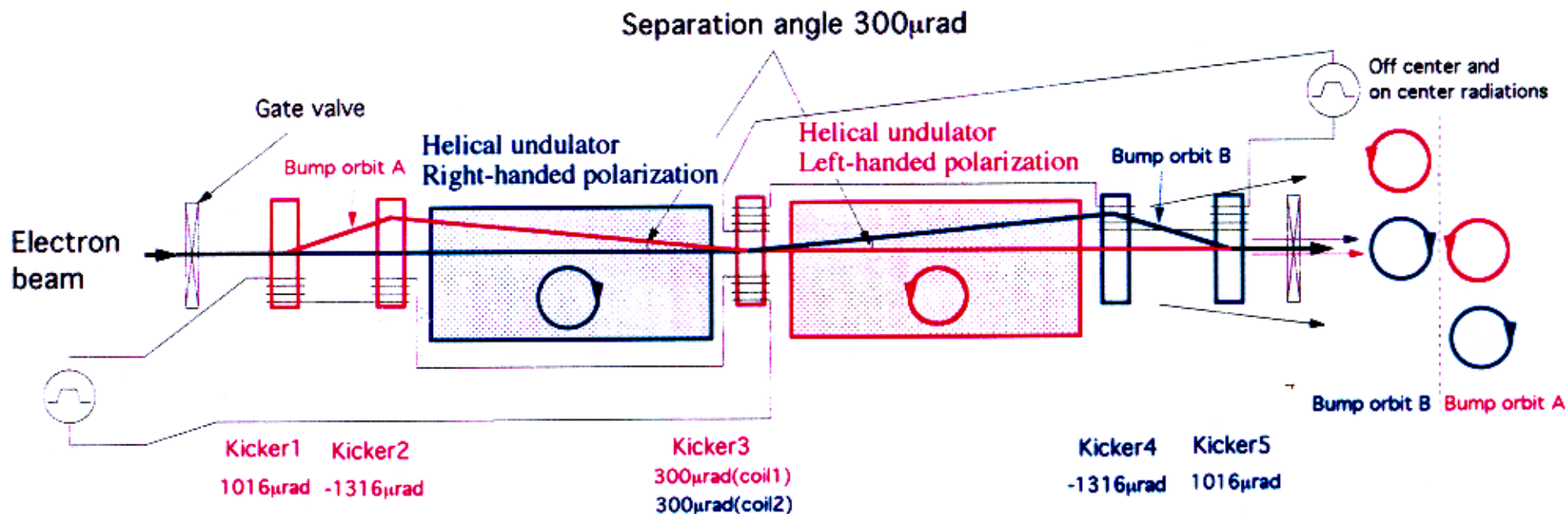


Elliptically / Circularly polarizing

Double Undulators

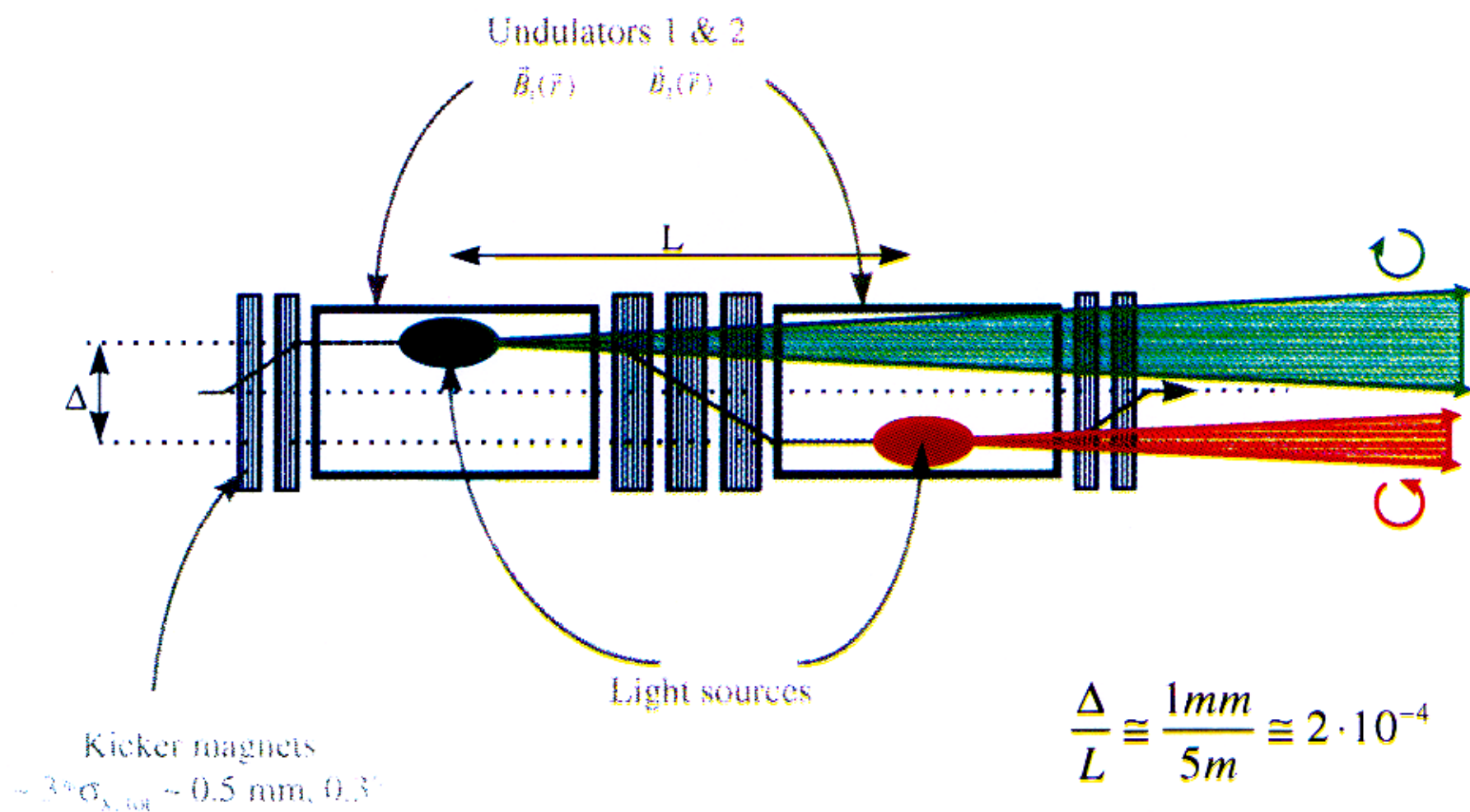
fast helicity switching!

design of undulator	Kicker magnets		Status
	design	operation	
permanent magnet	electromagnets	dynamically	under construction SPRING8
permanent magnet	permanent magnet	statically (chopper in beamline)	under construction BESSY
electromagnet quasiperiodic	electromagnets	statically (chopper)	design phase SLS
permanent magnet	electromagnets	statically (chopper)	design phase SLS



Twin helical undulator polarization switching

Parallel Displaced Beam



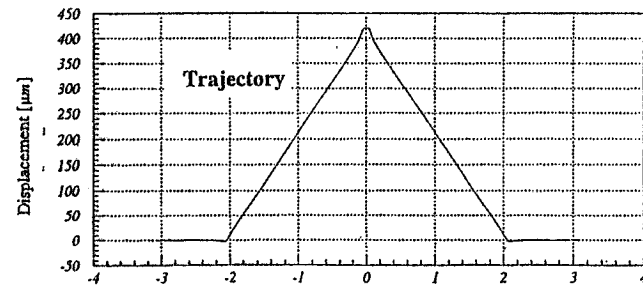
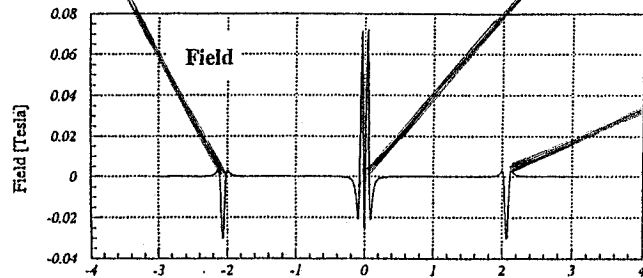
UE-56 Side View of Magnetic Structure

upstream undulator

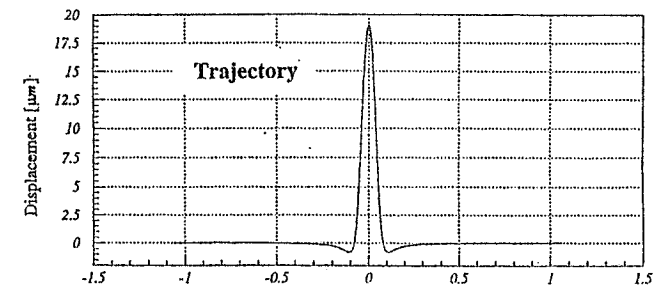
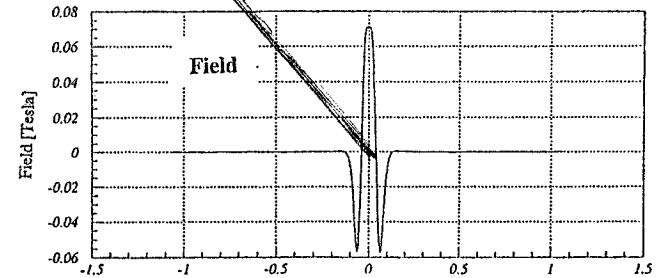
downstream undulator

Operation Mode 1

Operation Mode 2



Longitudinal Position [m]



Longitudinal Position [m]

In Vacuum Undulators / Wigglers

machine studies at ESRF:

0,8mm gap $\rightarrow$ 2h lifetime

ok from machine point of view
if topping up mode is active

but open questions concerning

- degradation of magnets (ID is scraping the beam)

- radiation shielding (Bremsstrahlung, Neutrons)
 $\rightarrow$ optimization of injection efficiency
not only injection rate in topping up mode

no lifetime reduction for

gap	lifetime	facility
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> 5	39h	ESRF
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> 4	14h	NSLS ($\beta_x = 1,7m, \beta_y = 0,3$)
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scraper somewhere in the ring does not
necessarily protect the injection device

strong focussing inside undulator (Tatchum)

would help $\rightarrow$ strong influence on lattice
additional quads etc...

Bypass would be fine for test:

mini β -sections

ALS-study

$\beta_y = 0,06m$

$\beta_x = 3m$

additional 6 quads/half stage

10cm available for ID

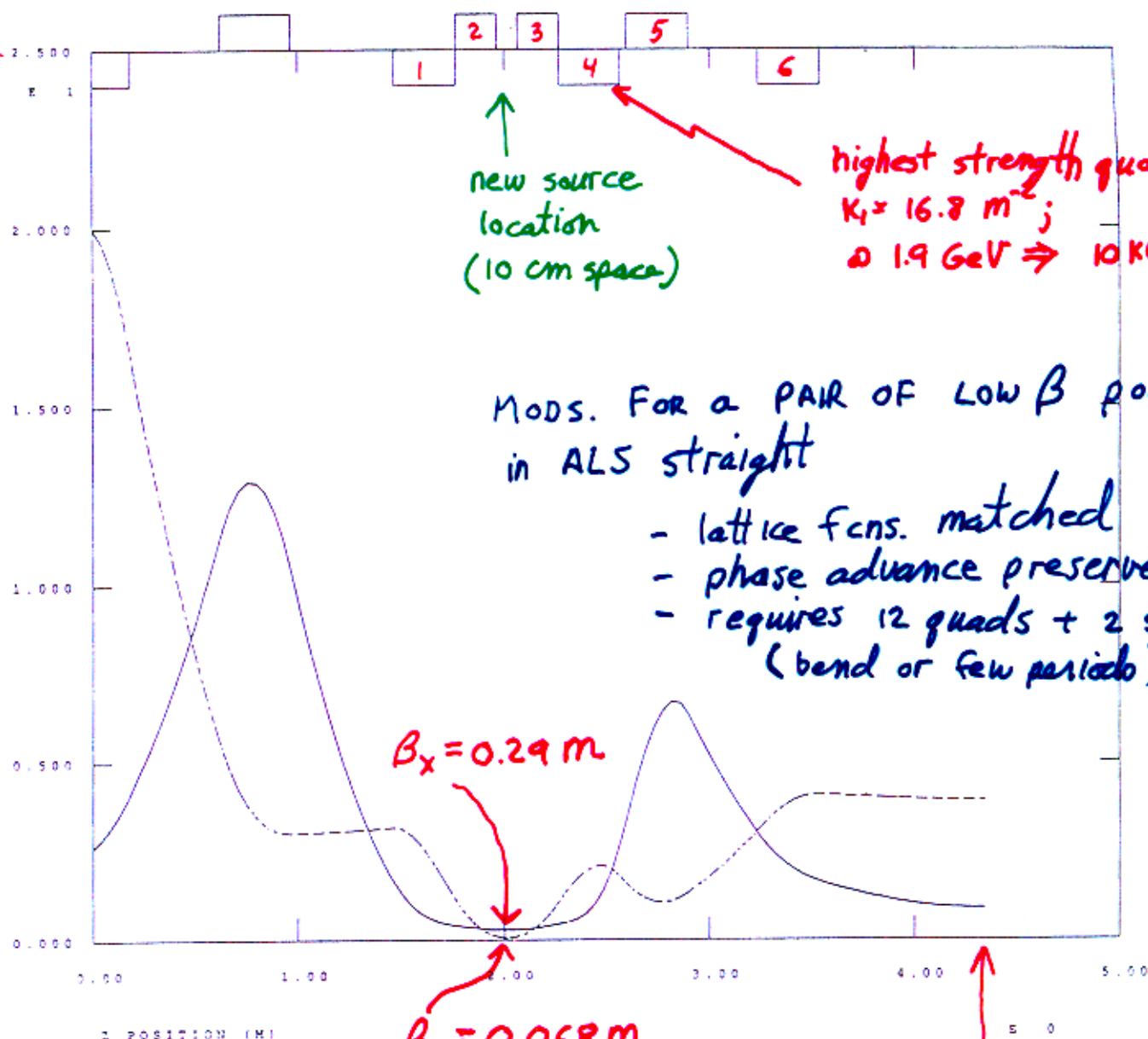
existing quads

6 new quads per half-straight

BETAX, BETAY 10.0* (ETAX)

14-FEB-1997 16:29:08

existing
lattice
continuous



In Vacuum Undulator Technology (SPRINGS driving force.)

magnet coating $\rightarrow$ Ti + TiN

after heating : $6 \cdot 10^{-11}$ Torr

image current heating : $50 \mu\text{Ni} + 10 \mu\text{Cu}$ foil

RT fingers water cooled

skimming technique : — magnet chips at
backside (SPRING)
conventional skimming
(ESRF)

magnet material high coercive force required

Nd Fe B (SPRING)

$\text{Sm}_2\text{Co}_{17}$ (ESRF)

thermal expansion during baking : careful design.

problems seem to be solved

$\Rightarrow$ even more ambitious plans

— in vacuum revolver

— 25 m long in vacuum undulator

flexible chamber as expensive as

in vacuum undulator $\rightarrow$ no need for it

nevertheless : continuous monitoring of ID ^{quality}

— routinely checking field integrals of IDs
(done every month at ESRF)

— reference spectra are even more sensitive
but might interfere with user activities

- i) shape of higher harmonics
- ii) polarization

superconducting planar undulators (Backe)

development at Forschungszentrum Karlsruhe

$$\lambda = 3.8 \text{ mm}$$

$$B = 0.56 \text{ Tesla}$$

$$N = 100$$

$$I_{\text{max}} = 1400 \text{ A}$$

$$\text{gap} = 2 \text{ mm}$$

already tested at HAMI Microtron (Mainz, Germany)

one has to go far into saturation to gain field compared to permanent magnet design.

In this case, however, field errors due to winding errors dominate machining errors.

superconducting variable period undulator (Tatchyn)

variable polarization can be provided

Codes

- Spectrum calculation including diffraction wavefront propagation through beamlines
- magnetic field calculations $\rightarrow$ RADIA (ESRF)